

35.C13584 Div. I

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MASAKI MIZUTANI ET AL. ) Examiner: S. Rao  
Div. of Appln. No.: 09/333,019 ) Group Art Unit: 2814  
Filed: Herewith )  
For: METHOD OF PRODUCING )  
SEMICONDUCTOR THIN FILM )  
AND METHOD OF PRODUCING )  
SOLAR CELL USING SAME ) March 20, 2001

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The present application is a division of co-pending Application No. 09/333,019. This Information Disclosure Statement is filed to make of record all prior art citations found in the parent and all references Applicants deem relevant to the patentability of the presently claimed subject matter.

The concise explanation of relevance for the non-English documents JP 7-302889 and JP 8-213645 is provided



in the form of English language abstracts. Further, U.S. Patent Nos. 5,856,229 and 5,811,348 cited herein correspond respectively to these Japanese documents.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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